

PHASE CONTROL THYRISTORS

www.DataSheet4U.com

- **Junction Size:** Square 370 mils
- **Wafer Size:** 4"
- **V_{RRM} Class:** 1200 V
- **Passivation Process:** Glassivated MESA
- **Reference IR Packaged Part:** IRKT56 Series

Major Ratings and Characteristics

Parameters	Units	Test Conditions
V _{TM} Maximum On-state Voltage	1.2 V	T _J = 25°C, I _T = 25 A
V _{RRM} Reverse Breakdown Voltage	1200 V	T _J = 25°C, I _{RRM} = 100 μA (1)
I _{GT} Max. Required DC Gate Current to Trigger	150 mA	T _J = 25°C, anode supply = 6 V, resistive load
V _{GT} Max. Required DC Gate Voltage to Trigger	2 V	T _J = 25°C, anode supply = 6 V, resistive load
I _H Holding Current Range	5 to 200 mA	Anode supply = 6 V, resistive load
I _L Maximum Latching Current	400 mA	Anode supply = 6 V, resistive load

(1) Nitrogen flow on die edge.

Mechanical Characteristics

Nominal Back Metal Composition, Thickness	Cr - Ni - Ag (1 KA - 4 KA - 6 KA)
Nominal Front Metal Composition, Thickness	100% Al, (20 μm)
Chip Dimensions	370 x 370 mils (see drawing)
Wafer Diameter	100 mm, with std. <110> flat
Wafer Thickness	370 μm ± 10 μm
Maximum Width of Sawing Line	130 μm
Reject Ink Dot Size	0.25 mm diameter minimum
Ink Dot Location	See drawing
Recommended Storage Environment	Storage in original container, in dessicated nitrogen, with no contamination

IR370BG12DCB

Bulletin I0201J rev. A 02/97

International
IR Rectifier

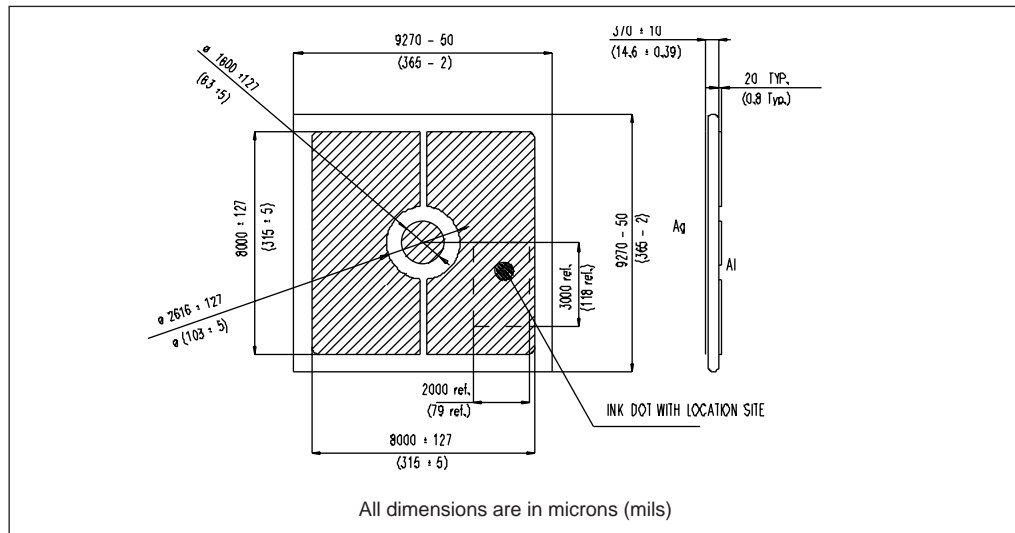
Ordering Information Table

www.DataSheet4U.com

Device Code						
IR	370	B	G	12	D	CB
①	②	③	④	⑤	⑥	⑦

- 1** - International Rectifier Device
- 2** - Chip Dimension in Mils
- 3** - Type of Device: B = Wire Bondable SCR
- 4** - Passivation Process: G = Glassivated MESA
- 5** - Voltage code: Code x 100 = V_{RRM}
- 6** - Metallization: D = Silver (Anode) - Aluminium (Cathode)
- 7** - CB = Probed Uncut Die (wafer in box)
None = Probed Die in chip carrier

Outline Table



Wafer Layout

www.DataSheet4U.com

